



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Bor-Wen Chan, et al.

Serial No.: 10/780,513

Filed: February 17, 2004

For: METHOD TO FORM A METAL
SILICIDE GATE DEVICE

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Attorney Docket No.
2003-0485 / 24061.524

Customer No. 42717

Group Art Unit: 2813

Examiner: James M. Mitchell

Confirmation No.: 1381

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
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on September 23, 2005
Kelly A. Morneau
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AMENDMENT UNDER 37 CFR §1.111

This Amendment is submitted in reply to the Office Action mailed on June 29, 2005.
(Please see the pages that follow).

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